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** CONTINUING DATA *****

J.W.S.

** FOREIGN APPLICATIONS *****

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35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	4	10	3
Verified and Acknowledged	<i>J.W.S.</i> Examiner's Signature Initials				

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TITLE Semiconductor device using low-k material as interlayer insulating film and including a surface modifying layer
Semiconductor device using low k material as interlayer insulating film and its manufacture method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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